

Mirror MEMS Variable Optical Attenuator



Product Introduction

Mirror MEMS Attenuators are based on a micro-electro-mechanical system (MEMS) technology. The MEMS attenuators design achieves highly repeatable optical attenuation over C and/or L band through an electrically movable mirror on silicon.

Features

- Low insertion loss
- Compact size
- Available in both normally open and normally closed states
- Excellent reliability

Applications

- Power equalization in multi-channel, optically amplified networks
- Gain-tilt control in erbium doped fiber amplifiers (EDFAs)
- Dynamic Gain/Channel Equalizers (DGE/DCE) in DWDM/CWDM networks, For ROADM power balance
- Photoreceiver trimming
- Receiver protection/switch during transmitter turn-ons

Standards

- Telcordia GR-1221-CORE
- RoHS

Specifications

Parameter		Unit	Value		
			Min	typical	Max
Wavelength		nm	C Band 1528-1565 L Band 1		Band 1570-1607
Insertion Loss		dB			0.8
Return Loss		dB	40		
Attenuation Range		dB	30		
PDL	0~15	dB			0.3
	15~20				0.5
TDL	0~15	dB		0.5	0.6
	15~20			0.8	1
Response time		ms			10
Polarization Mode Dispersion		ps			0.1
Maximum Optical Power		mW			300
Repeatability		dB			0.1
Operation Temperature		$^{\circ}$	-5~+65		
Package		mm	Ф5.35х26		

Note: 1. All insertion loss don't include connector loss.

